

UNITED STATES DEPARTMENT OF COMMERCE

PATENT AND TRADEMARK OFFICE

PATENT

In the application:

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Inventors: HE, Ting et al.  
Serial Number: 10/757,302  
Filed: January 14, 2004  
For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM  
FOR MATERIAL COMBINATORIAL STUDIES  
Group Art Unit: 1763  
Examiner: Richard R. Bueker  
Atty. Docket No.: 3994994-148069  
Confirmation No.: 4457  
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**RCE and Amendment in Response to Final Office Action Mailed 11/22/2010**

*By E-file [registered user] on MARCH 21, 2011*  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

To the Honorable Commissioner:

This Request for Continued Examination (RCE) and Amendment is filed in response to the Office Action mailed 11/22/2010. Please consider the remarks and amendments herein prior to further examination of the above-identified application.

This response includes:

- 1) Amendments to the Claims begin on page 2; and
- 3) Remarks begin on page 6.

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